



TJW

PATENT
Attorney Docket No. 04329.3304-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Ayako NAKANO et al.)
Application No.: 10/823,539) Group Art Unit: 1756
File: April 14, 2004) Examiner: Stephen D. ROSASCO
For: PATTERN FORMING METHOD AND) Confirmation No.: 4440
SYSTEM, AND METHOD OF)
MANUFACTURING A)
SEMICONDUCTOR DEVICE)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed June 1, 2007, the period for response to which extends through September 4, 2007 (September 1 being a Saturday and September 3 being a federal holiday), please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.